# IV International Conference on Ultrafast Optical Science "UltrafastLight-2020"

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# 3D microfabrication of large-scale objects in glass using an ultrafast laser

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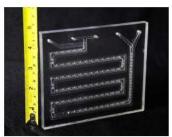
XXL - THE EXTREME OPTOELECTROMECHANIX LAB

# What are we going to talk about today?

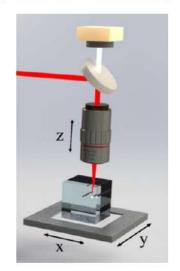
 3D printing: large scale but still of micrometer-scale resolution



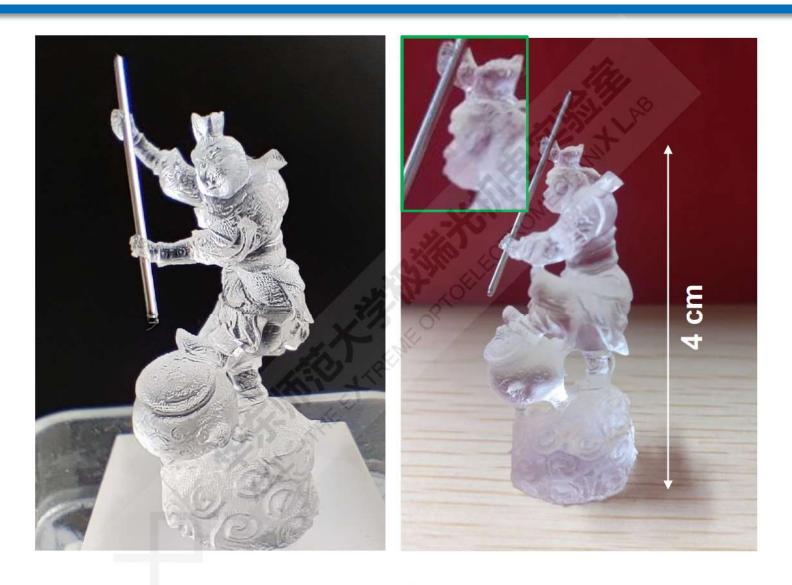
 Chemical microreactor: microdevices for chemistry industrial application



 Only a laser is allowed to be used for making these structures.



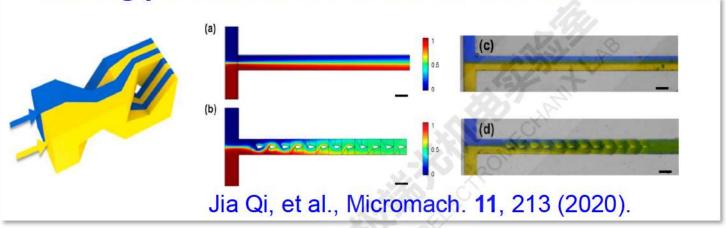
# 3D printing: large scale but still of high resolution

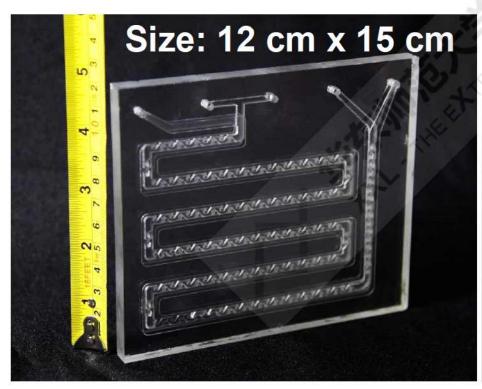


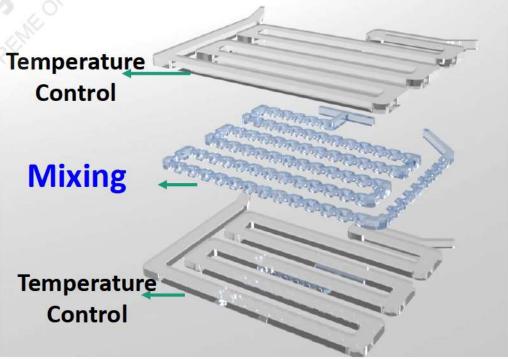
Statue of Monkey King fabricated out of glass (Height: 4 cm; XYZ resolution: 15 μm)

# Microreactor for industrial applications

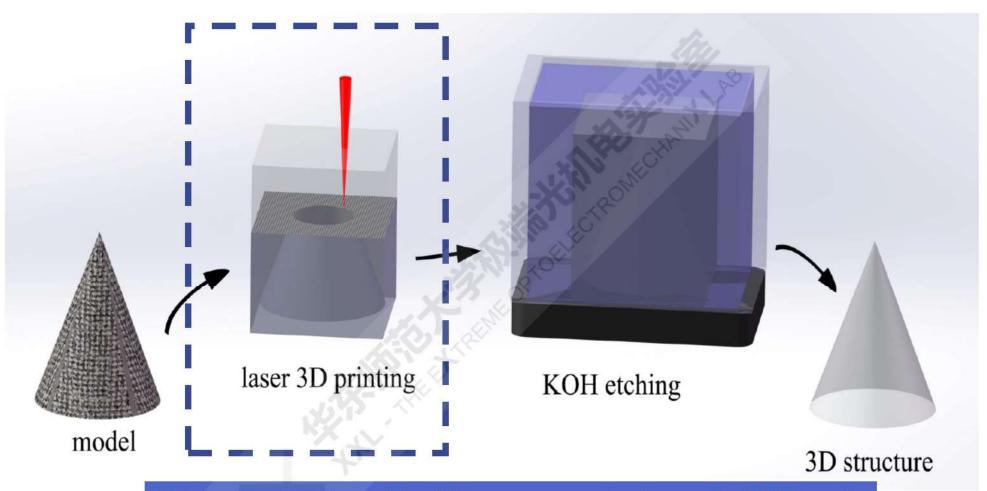
### Mixing performances in the 1D and 3D channels







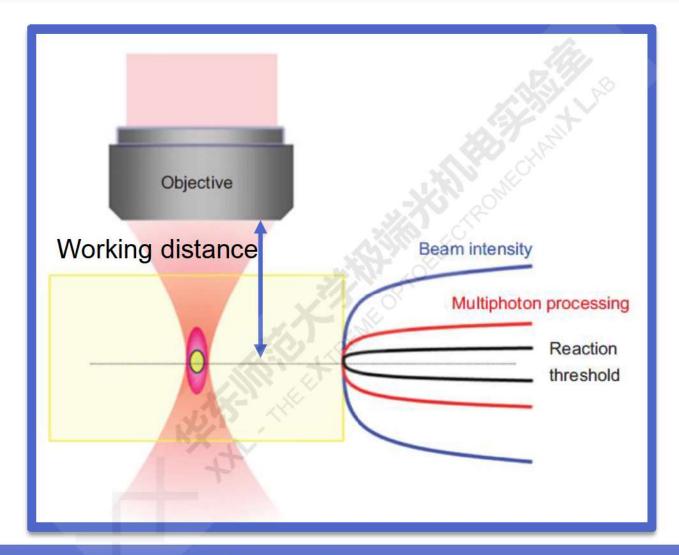
# Technique: selective laser-induced etching



Originally developed by Misawa group in Japan in 2000 and then improved by many groups all around the world.

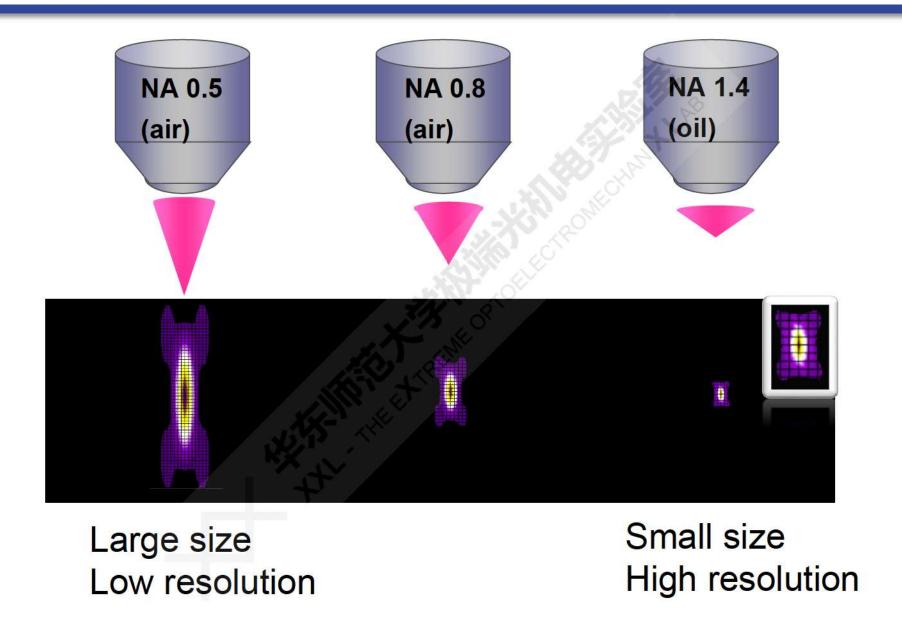
A subtractive process that can produce structures with unspoiled material properties.

# Mechanism: multiphoton absorption inducing modification



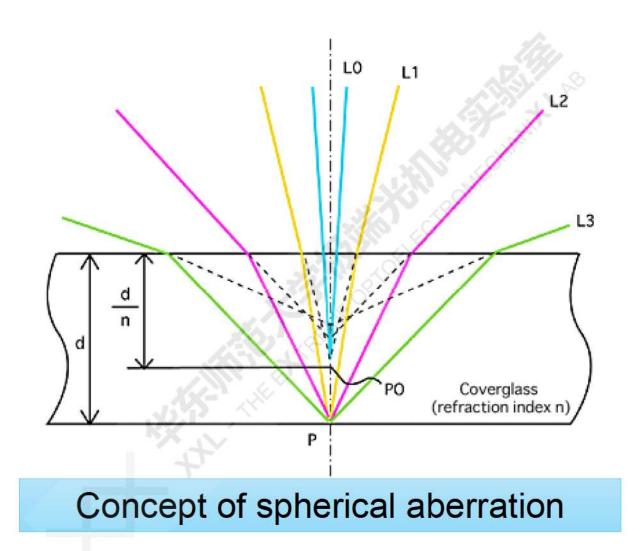
Highest achievable resolution: ~1 μm
Thickness of sample: less than 1 mm limited by lens working distance

# The challenges for large scale glass printing



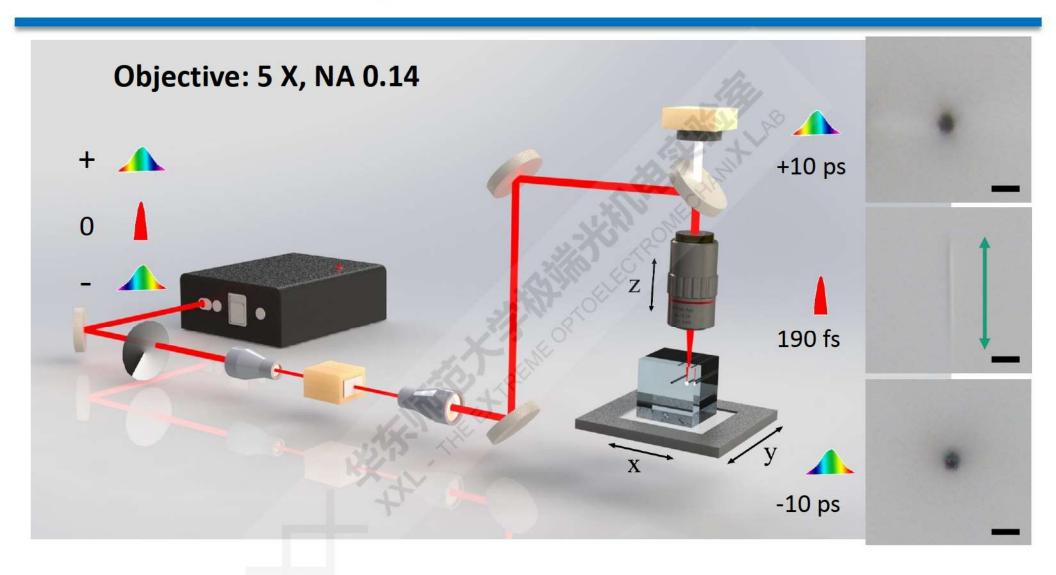
1. Long working distance inherently associated with low resolution!

# The challenges for large scale glass printing



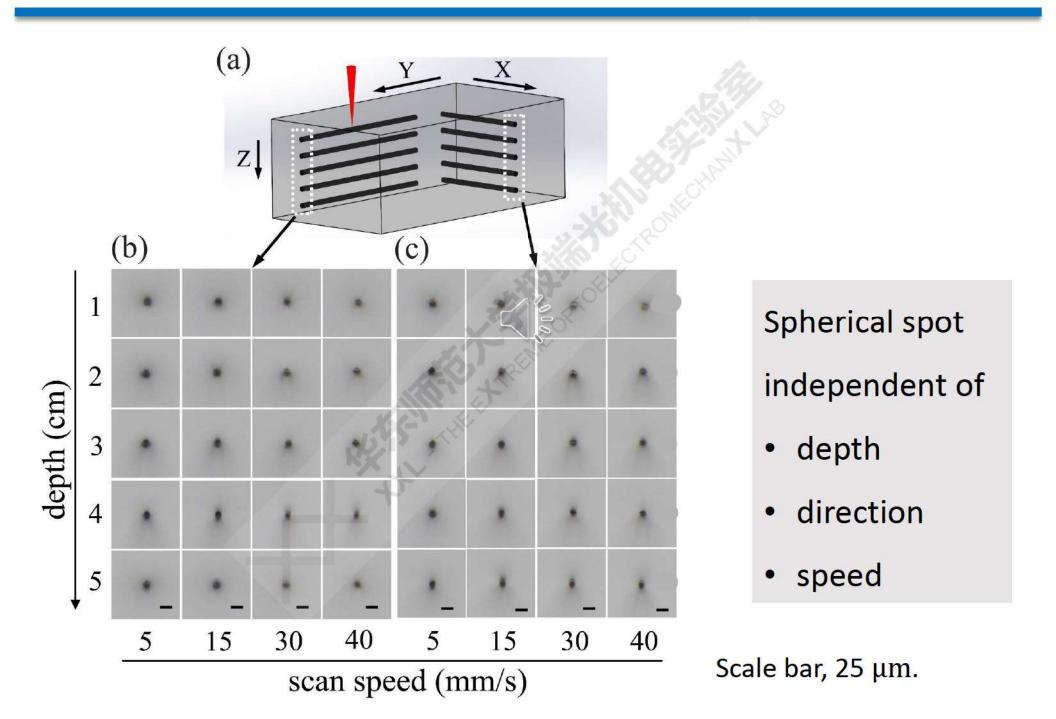
2. Focusing deeply into glass inherently leads to low axial resolution!

## Our solution: chirped femtosecond laser modification

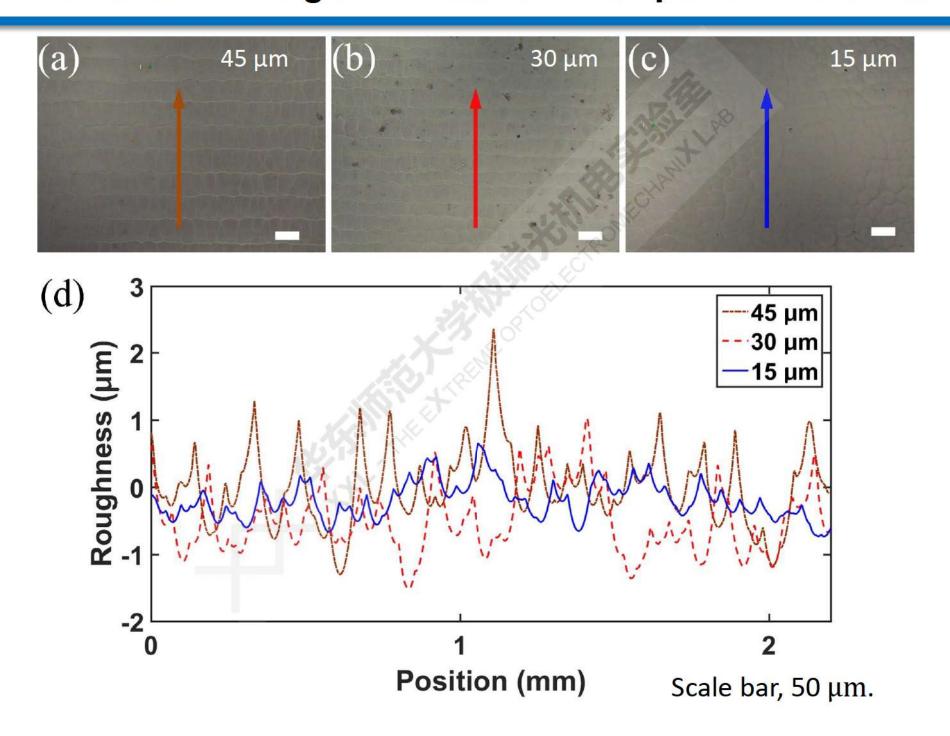


Schematic of the experimental setup. Scale bar, 25  $\mu m$ .

# Cross-section of lines written by 10 ps laser pulses



## Evidence showing a resolution of ~15 µm in Z direction



# Another challenge: controlling chemical etching



We can produce isotropic, aberration-free modification in glass. But this is not sufficient.

Due to the well-known nanograting effect, the chemical wet etching depends on the orientation of polarization of the writing beam. How can we remove such dependence to achieve homogeneous writing of complex 3D structures?

# Polarization sensitivity vs pulse duration

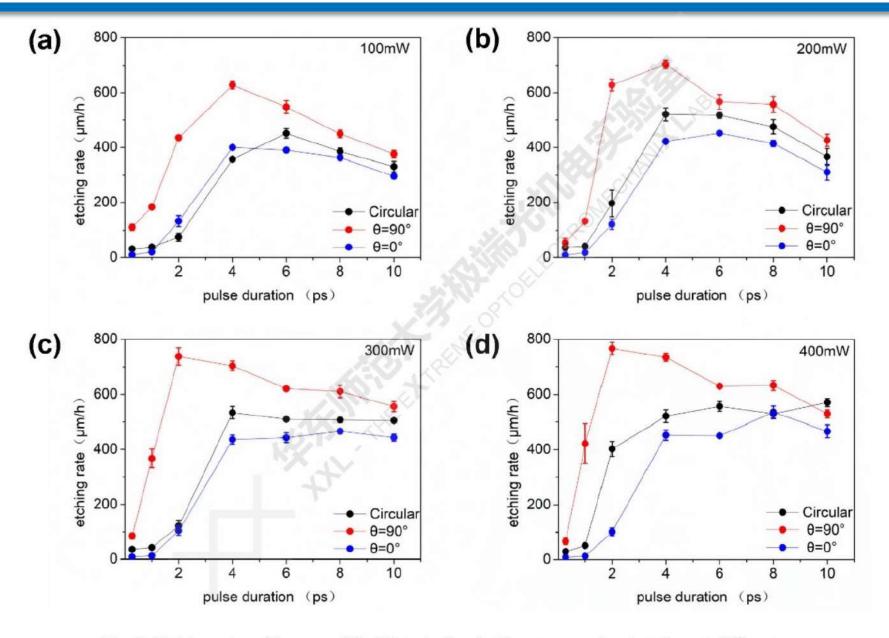
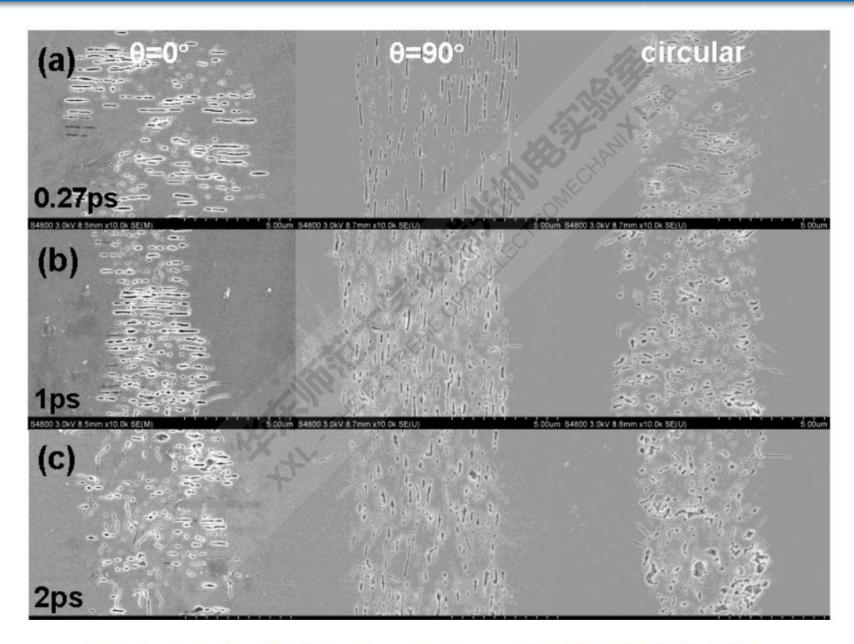


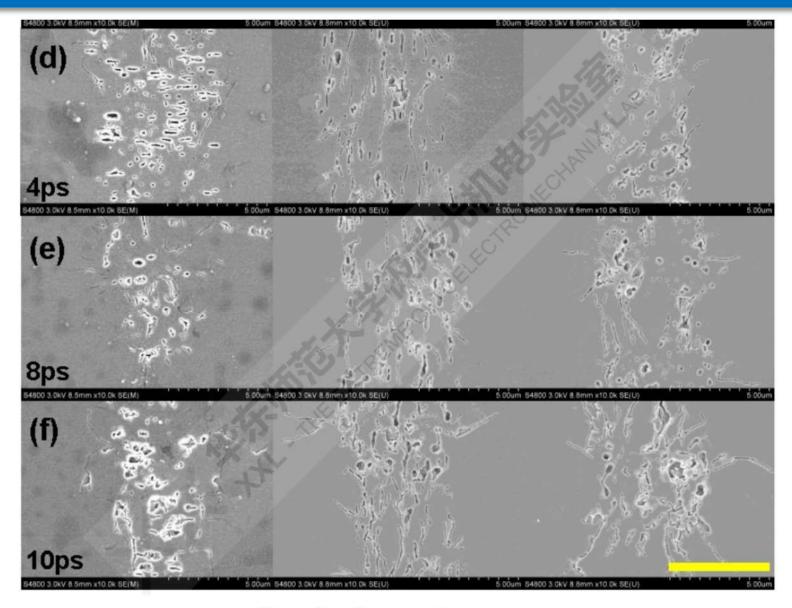
Fig. 2. Etching rates of laser modified lines in fused silica versus pulse durations at different polarization conditions and laser powers: (a) 100 mW; (b) 200 mW; (c) 300 mW; (d) 400 mW.

# **Shorter pulses: nanogratings**



X. Li, et al, Applied Surface Science 485 (2019) 188-193

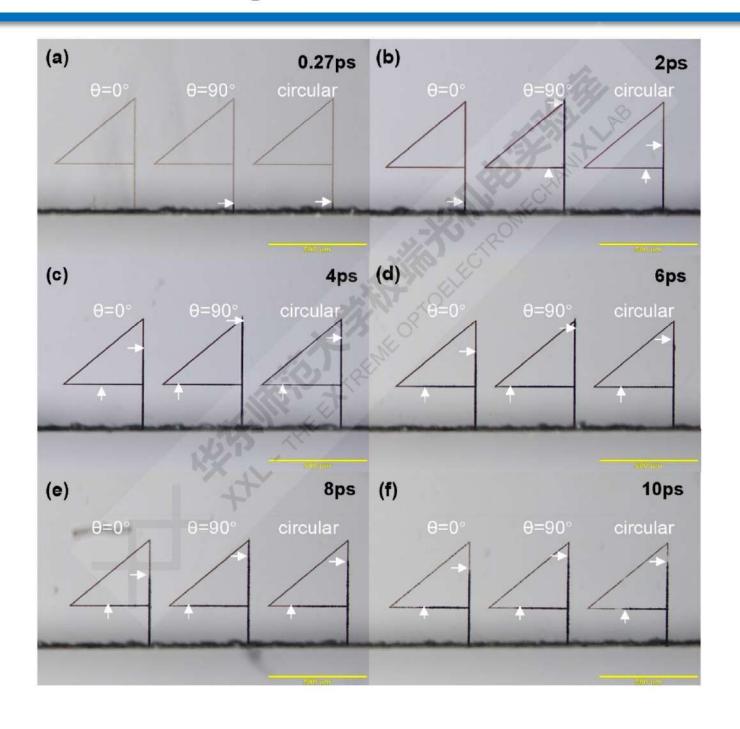
# Longer pulses: stress induced cracks along scan direction



Scale bar: 5 μm

X. Li, et al, Applied Surface Science 485 (2019) 188-193

# Selective etching independent of polarization



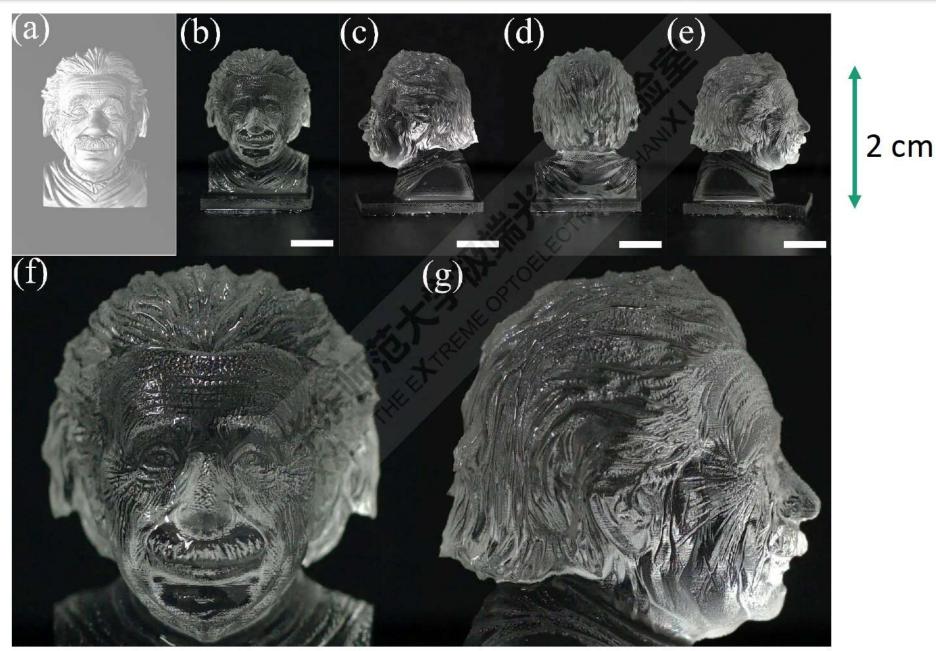


Maintain the high resolution at large and variable depth.

Produce polarization insensitive internal modification.

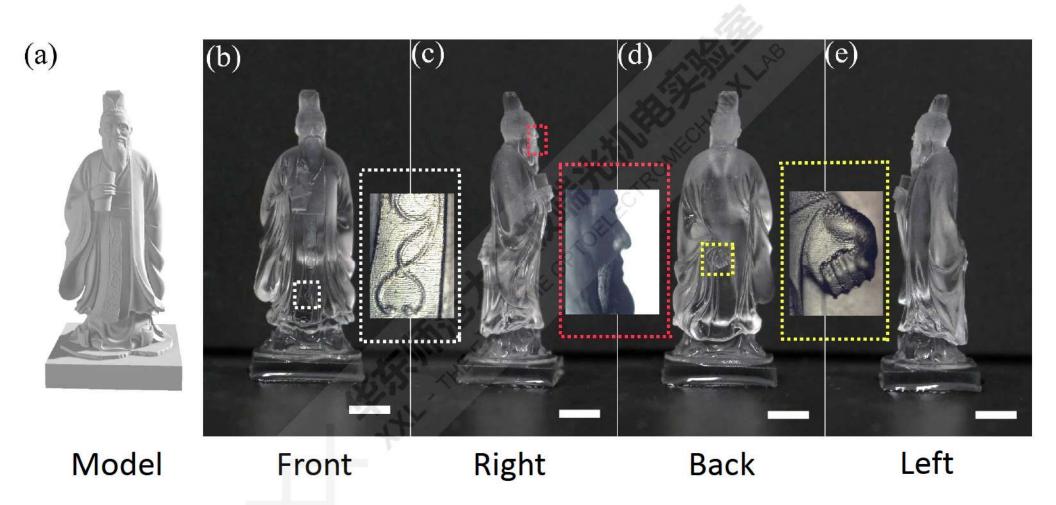
With the picosecond laser, the difficulties in maintaining the high axial resolution at large and variable depth and in achieving the polarization insensitive internal modification can be overcome at once! We can move on to practice the 3D glass printing using these unusual yet lucky findings.

# Structures: Einstein of a height of 2 cm



Scale bar, 5 mm.

# Structures: Confucius of a height of 3.8 cm

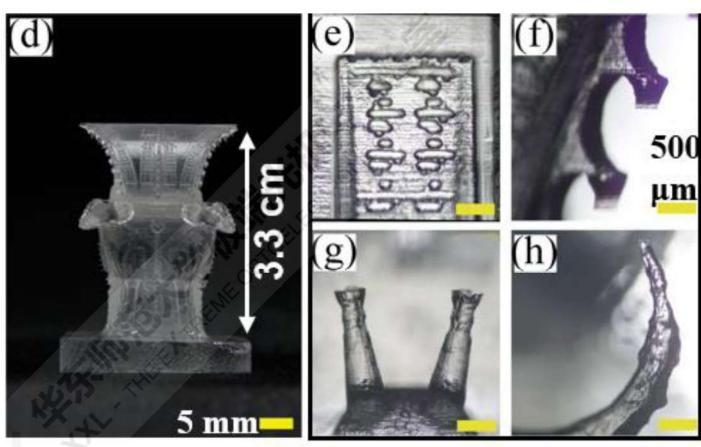


P. Wang et al, Micromachines **2019**, 10, 565; doi:10.3390/mi10090565

Scale bar, 5 mm.

# Structures: Four-ram Zun (B. C. ~1000 yrs, China)

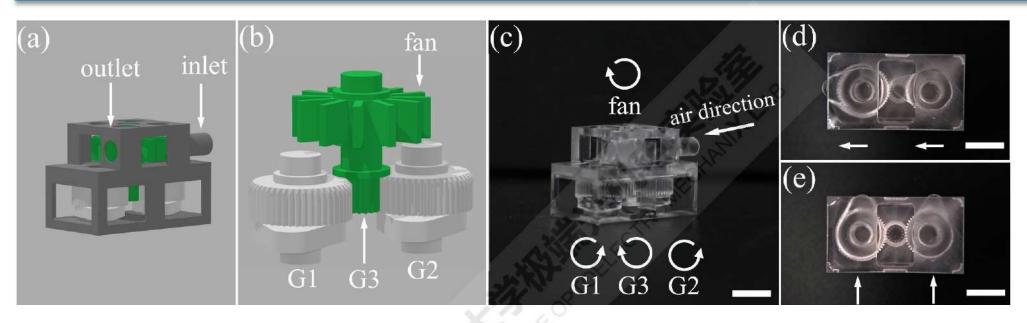




# Statue of Four-ram Zun one of the most famous bronze ware

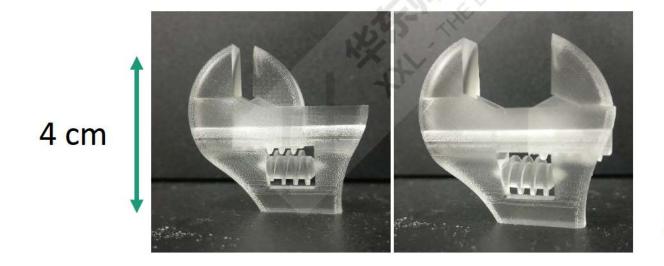
H. Zhang et al, Submitted for publication

# Structures: micromachines with movable parts



Air turbine

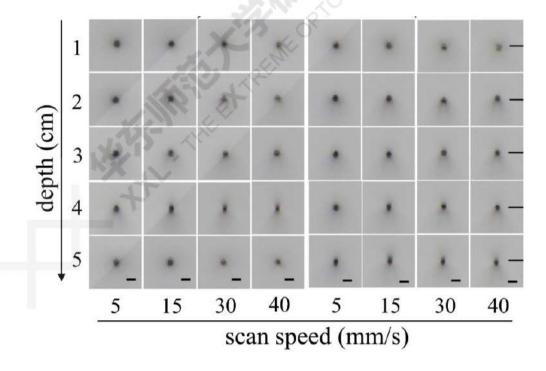
Scale bar, 5 mm.



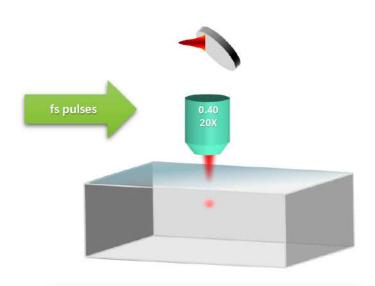
Adjustable wrench

# New physics of uniform and isotropic XYZ resolution along Z axis:

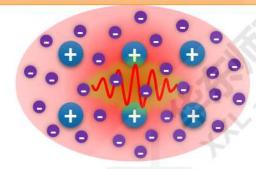
# Incubation induced localization



# General physics of ultrashort laser-material interaction



#### (b) Plasma absorption

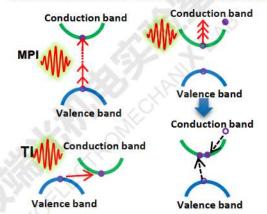


Critical plasma density:

$$\begin{split} & \rho_c = \epsilon_0 m_e \omega_0^2 / e^2, \\ & \rho_c \sim & 10^{21} \text{ cm}^{-3} \ @ \ 800 \text{nm}. \end{split}$$

#### (a) Free electron generation

#### Photoionization & Avalanche ionization



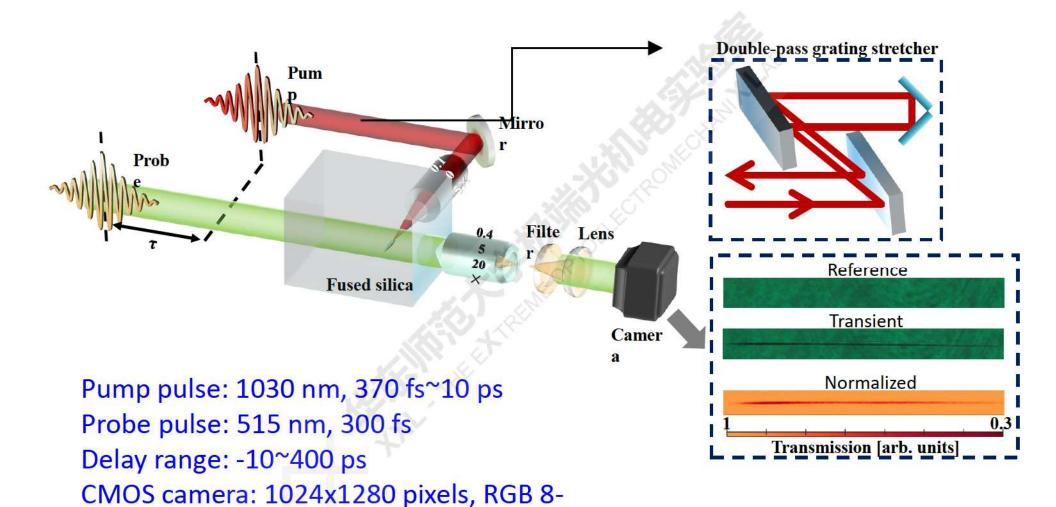
#### (c) Lattice heating & relaxation



Hot plasma energy transfer to the lattice (~10ps), Shock wave generation (~100ps), Thermal diffusion (~10ns), Resolidification (~1μs).

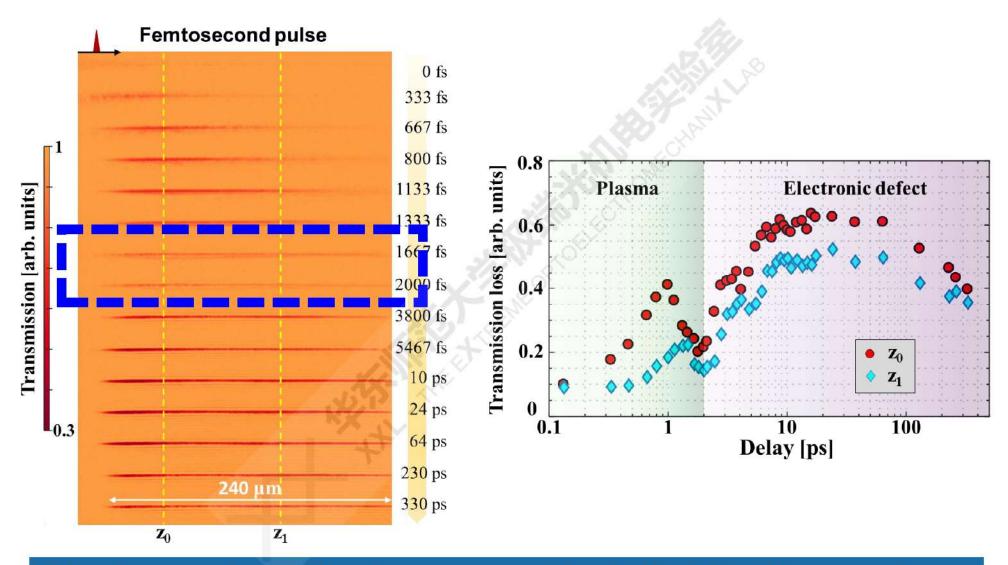
- R. R. Gattass & E. Mazur, *Nat. Photonics* 2, 219 (2008).
- R. Osellame et al., Femtosecond Laser Micromachining (2012).
- K. Sugioka & Y. Cheng, Light: Sci. Appl. 3, e149 (2014).

### Pump-probe measurement revealing plasma dynamics



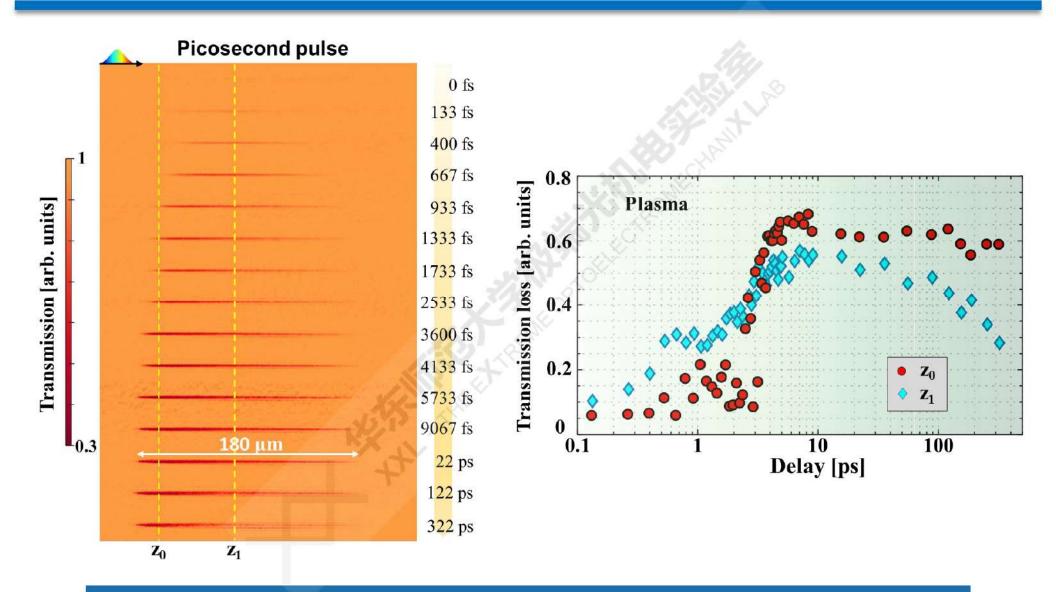
bit/16-bit dynamic range

## Plasma images from 0 fs to 330 ps: single fs pulses



The plasma absorption becomes weaker in the blue frame and then again gets stronger. Dynamics plotted in the right panel.

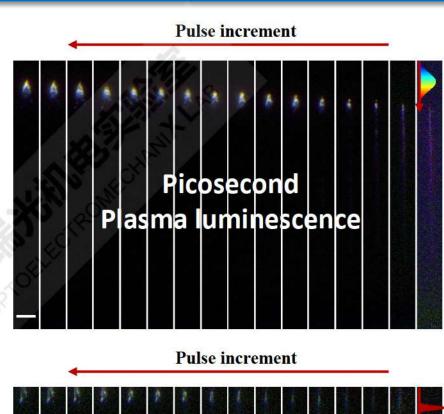
### Plasma images from 0 fs to 322 ps: single chirped ps pulses

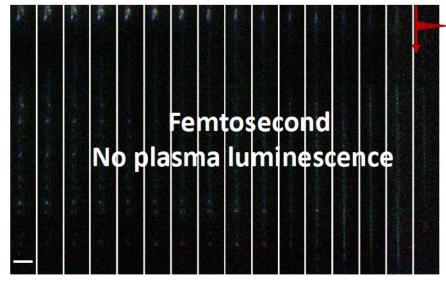


The plasma absorption keeps going stronger until saturates. Dynamics plotted in the right panel.

# Multiple-pulse incubation effect

- 1. For picosecond pulses, incubation leads to highly localized and strong plasma luminescence !!!
- 2. Localization should be a result of light blockage by the high-density plasma.
- 3. This could be a universal effect in various transparent materials but need to be checked!





# Can this technique be economically valuable for the mankind?

YES!

First example: chemistry

# Challenges in traditional chemical reaction







1956 2008

# Nothing has changed in nearly 500 years



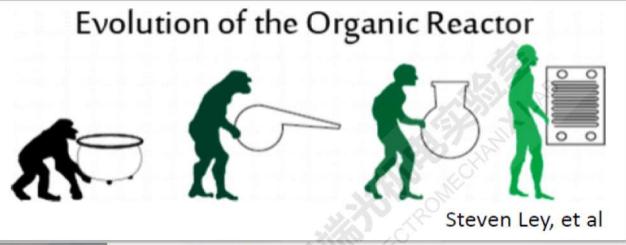


### Big issues:

- Low reaction efficiency
- High reagent consumption
- ➤ Poor scalability
- Low heat diffusion

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# New trend: miniaturization of reactor





### **Benefits:**

- > **Higher** reaction rates
- Purer products
- Better safety

- Integration of synthesis and analysis steps
- Rapid optimization
- Easy scale-up
- Reaction conditions not possible using traditional methods

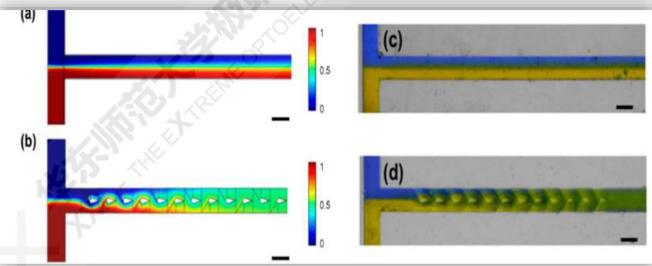
# Concept of a 3D microreactor

### 3D mixing unit:

Schematic and internal 3D structure

(a) (e) 9.8µm

Performance comparison in 1D and 3D microchannels

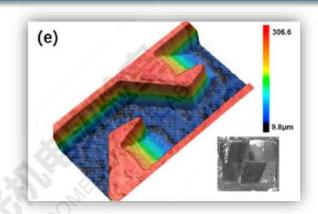


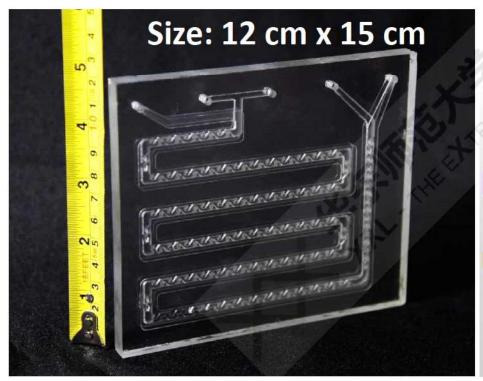
Mixing performances in 1D and 3D microchannels (Left: modeling; right: experiment)

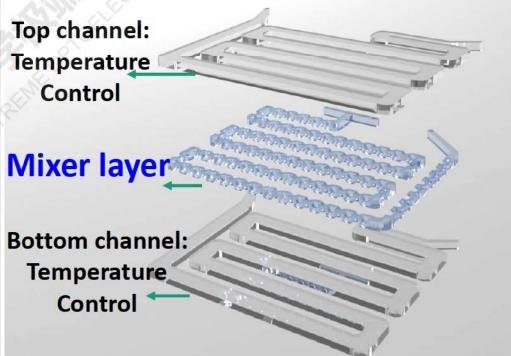
Jia Qi, et al., Micromach. 11, 213 (2020).

# Industrial scale 3D microreactor

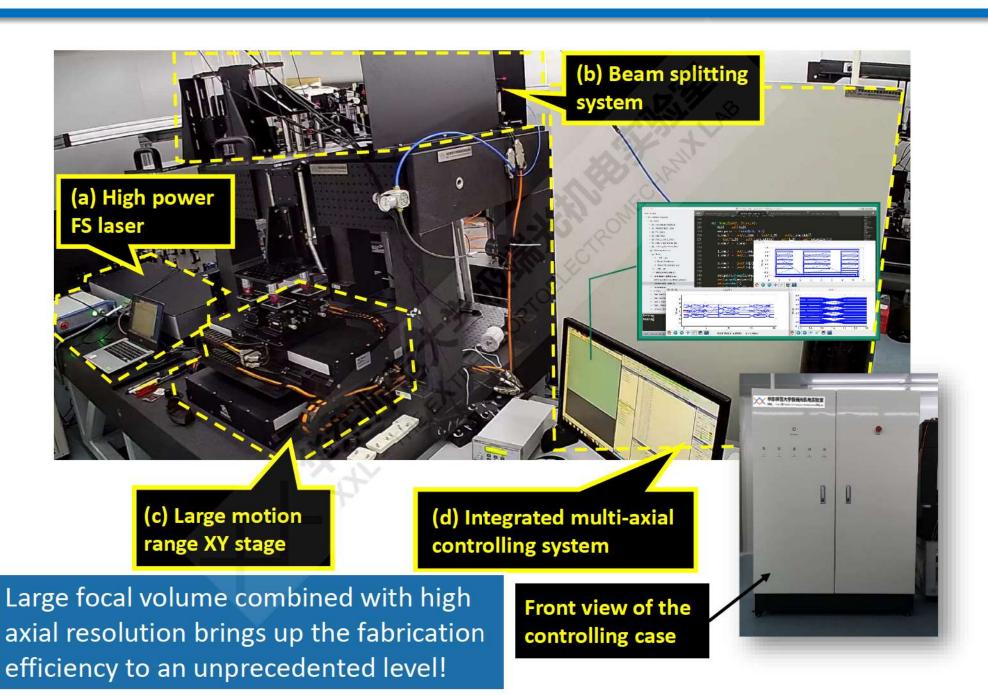




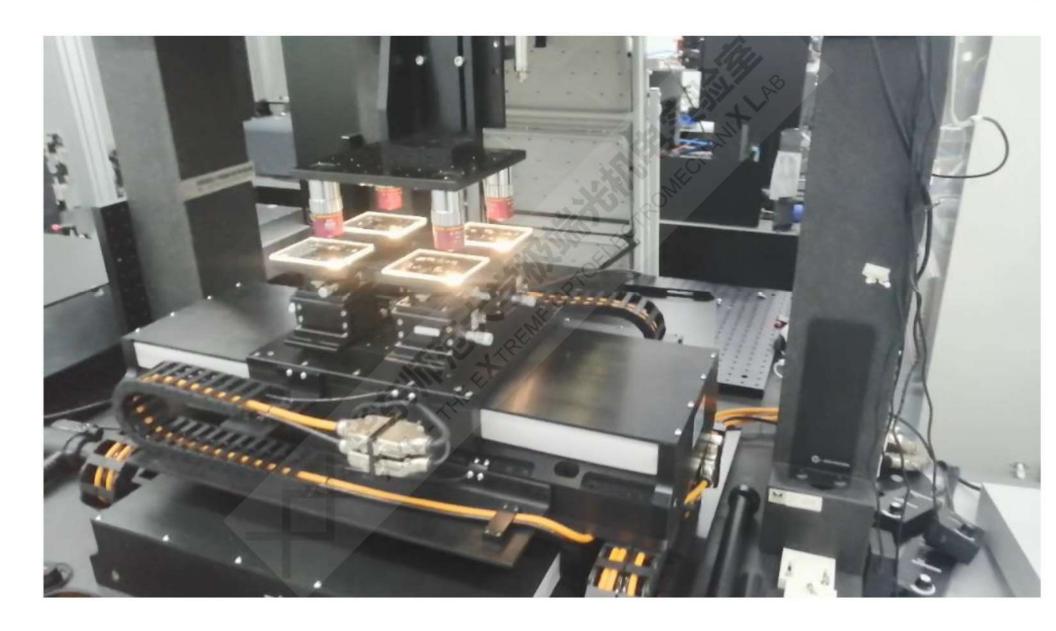




# Increase the efficiency with the chirped pulses



# Four-foci focal system for speeding up the fabrication



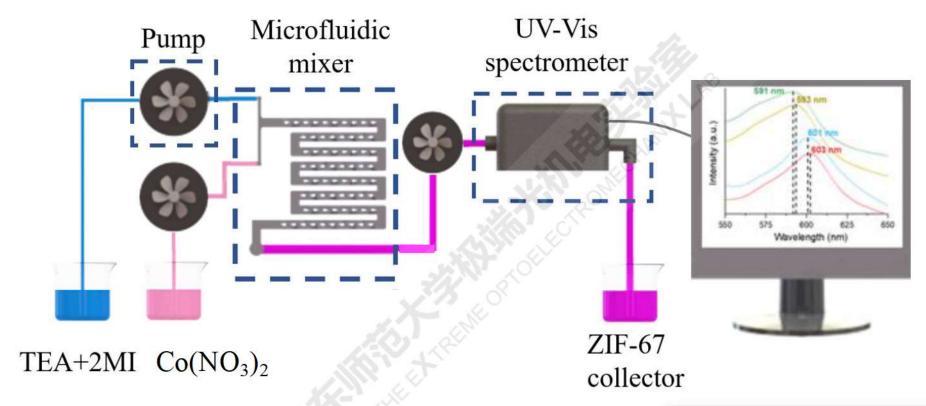
# Four-foci focal system for speeding up the fabrication



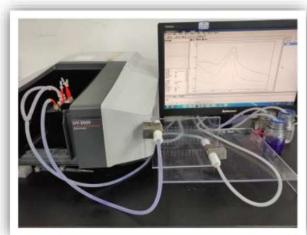
- 1. Four focal spots of individually tunable power
- 2. Large scale XY motion range of 30 cm by 30 cm
- 3. Inline real-time focus tracking system

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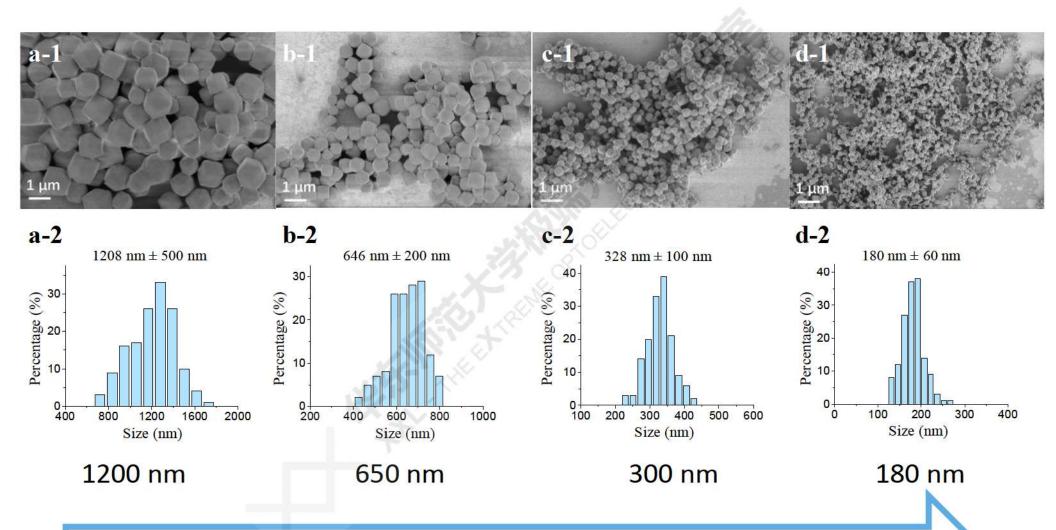
# Size-controlled flow synthesis of porous crystals



- 1. In-line monitoring of sizes of metalorganic frameworks (ZIF-67) crystals
- 2. Size-controlled flow synthesis



# Size-controlled flow synthesis of porous crystals



Size decreasing with increased concentration of an additive

## Just for fun: combining 3D printing and microfluidics

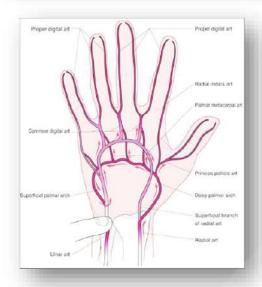
#### FULL PAPER





# Freeform Microfluidic Networks Encapsulated in Laser-Printed 3D Macroscale Glass Objects

Zijie Lin, Jian Xu,\* Yunpeng Song, Xiaolong Li, Peng Wang, Wei Chu, Zhenhua Wang, and Ya Cheng\*













### **Conclusions and outlook**

- 1. We show how to make large 3D structures in glass with a micrometer scale fabrication resolution. The opportunity provided by the nonlinear interaction between loosely focused femtosecond laser pulses and transparent material is truly beyond imagination and extremely valuable for various applications!
- We reveal the interesting new physics which exclusively exists in the multi-shot interaction regime between femtosecond laser pulses and glass.
- We demonstrate fabrication of chemistry reactors for industrial applications taking the advantages of the findings.

# Acknowledgment















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- Shanghai Municipal Science and Technology Major Project
- Key Project of the Shanghai Science and **Technology Committee**







National Natural Science Foundation of China



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Thank you for your listening!